



# EMPC2009

17<sup>th</sup> European Microelectronics  
and Packaging Conference & Exhibition



International Microelectronics  
And Packaging Society  
Italian Chapter



EMPC 2009 [www.empc2009.org](http://www.empc2009.org)

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# PROGRAMME OVERVIEW

Tutorials, Monday June 15 <sup>th</sup>				
AM	Changing Role of Packaging from Packaging of ICs to Packaging of Systems with High Impact Rao Tummala Georgia Tech	Physical and Electrical Design Modelling Prof Flavio Canavero Turin Polytechnic	Electronic Package Reliability N Sinnadurai	Wirebonding Technologies Seminar Part I H&K, ESEC, K&S ASM, F K Delvotec, Palomar
	<i>LUNCH</i>			
PM	TSV Technology for 3D Integration Latest developments EMC3D consortium	Advanced materials for power electronics packaging Dr.-Ing Schulz-Harder Mark A. Occhionero, Ph.D. Dr. Ing. Roberto Bellu	Mems and Sensors Applications Ciprian Iliescu A Star Singapore	Wirebonding Seminar Part II H&K, ESEC, K&S, ASM F K Delvotec, Palomar
	<i>WELCOME COCKTAIL</i>			

Tuesday, June 16 <sup>th</sup>				
	Session 1	Session 2	Session 3	Session 4
9.00	Conference Opening and Welcome			
9.10	Keynote <i>Overview of Packaging Technologies and Markets</i> J.C. Eloy, Yole			
9.50	Keynote <i>Automotive Package Reliability</i> B. Hauser, Bosch			
10.30	<i>POSTER SESSION AND COFFEE BREAK IN THE EXHIBITION AREA</i>			
11.20	Evolution of Current Packaging Technologies: Flip Chip packaging	Materials: Solder Joint Properties and reliability I	Optoelectronic Packaging	
13.00	<i>LUNCH</i>			
14.00	Evolution of Current Packaging Technologies: Embedded, Pop/Sip packages	Reliability I	Microfluidic, Medical Device Packaging	
15.40	<i>COFFEE BREAK IN THE EXHIBITION AREA</i>			
16.00	Evolution of Current Packaging Technologies Small form Factor	Reliability II	Ceramic Packages Including LTCC	Assembly Technology I: Wirebonding I
<i>GALA DINNER</i>				

# PROGRAMME OVERVIEW

Wednesday, June 17 <sup>th</sup>				
	Session 1	Session 2	Session 3	Session 4
9.00	Keynote <i>Power Packaging</i> N. Abbate, STMicroelectronics			
9.40	Keynote <i>Package Beyond 3D ICs to 3D Systems</i> R. Tummala, Georgia Tech			
10.20	<i>POSTER SESSION AND COFFEE BREAK IN THE EXHIBITION AREA</i>			
11.20	Advanced Packaging: wafer level Package I	High Power Packaging Technology	Electrical simulation	
13.00	<i>Lunch</i>			
14.00	Advanced Packaging: wafer level Package II	High Power Packaging: Thermal modeling and Management	Sensor Packaging	Materials: Adhesives Properties and reliability I
15.40	<i>Coffee Break in the Exhibition Area</i>			
16.00	Advanced Packaging: 3D packaging I	Materials: Solder Joint Properties and reliability II	Assembly Technology II	Substrates and Interconnects

Thursday, June 18 <sup>th</sup>				
	Session 1	Session 2	Session 3	Session 4
9.00	Keynote <i>Mems The future man machine interface</i> B. Vigna, STMicroelectronics			
9.40	Keynote <i>Heterogeneous Integration for System in Package</i> H. Reichl, Fraunhofer IZM			
10.20	<i>COFFEE BREAK</i>			
10.40	Advanced Packaging: 3D packaging II	Mems System Packaging	Materials: Adhesives Properties and Reliability II	IMAPS Global Business Council Photovoltaics
12.30	Technology Knowledge Gaps Projects arising from the iNEMI Technology Roadmap B. Pfahl, J. Arnold and G. O'Malley, INEMI			
12.50	Economic Recovery Through Technological Innovation and Creativity Chuck Bauer			
13.10	Conference Close and preview ESTC2010 and EMPC2011			

## TUESDAY, JUNE 16<sup>TH</sup>

9.00 Conference Opening and Welcome

9.10 **Overview of Packaging Technologies and Markets**

KEYNOTE SPEECH: *J.C. Eloy, Yole*

9.50 **Automotive Package Reliability**

KEYNOTE SPEECH: *B. Hauser, Bosch*

10.30 *POSTER SESSION AND COFFEE BREAK*

### Evolution of Current Packaging Technologies: Flip Chip packaging

11.20 **EMPC37 Advancements In Bumping Technologies for Flip Chip and Wlcsp Packaging**

*Dionysios Manassis<sup>1</sup>, Rainer Patzelt<sup>1</sup>, Andreas Ostmann<sup>2</sup>, and Herbert Reichl<sup>2</sup>*  
<sup>1</sup>Technical University Berlin, <sup>2</sup>Fraunhofer IZM

11.45 **EMPC127 Novel Interconnection Technique for Flip-Chip Packages; Self-Assembly Solder Bonding Technique**

*Susumu Sawada, Takashi Kitae, Seiji Karashima, Seiichi Nakatani, Tatsuo Ogawa*  
Panasonic

12.10 **EMPC57 New Flipchip Technology**

*Reinhard Windemuth*  
Panasonic Industrial Europe GmbH

12.35 **EMPC155 Characterization of oxidation of the electroplated Sn for advanced flip-chip bonding**

*W. Zhang, and W. Ruythooren*  
IMEC

### Materials: Solder Joint Properties and reliability I

11.20 **EMPC26 Reliability of 100 µm Bi- and In- Solder Balls**

*S. Kemethmüller, R. Dohle, J. Pohlner, Th. Dünne, J. Göbner*  
Micro Systems Engineering

11.45 **EMPC76 Effect of microstructure design on reliability of FBGA lead-free solder joints**

*F.X. Che, J.E. Luan*  
STMicroelectronics

12.10 **EMPC25 Investigation of Compliant Interconnect for Ball Grid Array (BGA)**

*Rolf Johannessen, Frøydis Oldervoll, Maaïke V. Taklo, Helge Kristiansen, Hallvard Tyldum, Hoang-Vu Nguyen, Knut Aasmundtveit*  
SINTEF ICT, Conpart AS, Norwegian University of Sciences and Technology (NTNU), Vestfold University College

12.35 **EMPC199 Addressing Opportunities and Risks of Pb-Free Solder Alloy Alternatives**

*Gregory Henshall* (Hewlett Packard), *Robert Healey*, *Ranjit S. Pandher* (Cookson Electronics), *Keith Sweatman*, *Keith Howell* (Nihon Superior), *Richard Coyle*, *Joe Smetana* (Alcatel Lucent), *Thilo Sack*, *Polina Snugovsky* (Celestica), *Stephen Tisdale*, *Fay Hua* (Intel) and *Grace O'Malley* (iNEMI)

### Optoelectronic Packaging

11.20 **EMPC52 Roll-To-Roll Manufacturing of Organic Photovoltaic Modules**

*M. Tuomikoski, P. Kopola, H. Jin, M. Ylikunnari, J. Hiitola-Keinänen, and J. Hast*  
VTT Technical Research Centre of Finland

11.45 **EMPC67 Fully embedded optical and electrical interconnections in flexible foils**

*E. Bosman, G. Van Steenberge, P. Geerinck, J. Vanfleteren and P. Van Daele*  
Ghent University

12.10 **EMPC34 Process Development for a Very Precise Placement of a Lens for Micro-Optics Based Components**

*Danilo Caccioli, Luca Maggi*  
PGT Photonics

12.35 **EMPC144 Packaging of silicon photonics devices: grating structures for high efficiency coupling and a solution for standard**

*Jose Vicente Galan, Amadeu Griol, Juan Hurtado, Javier Marti', Giovan Battista Preve, Pablo Sanchis*  
NTC Universidad Politecnica Valencia

13.00 *LUNCH*

### Evolution of Current Packaging Technologies: Embedded, Pop/Sip packages

14.00 **EMPC50 Joint project for mechanical qualification of next generation high density package-on-package (PoP) with through mold via technology**

*Didier Campos, Eric Saugier, Moody Dreiza, Jin Seong Kim, Lee Smith, Pauli Jarvinen*  
ST Microelectronics, Amkor Technology, Nokia

14.25 **EMPC133 A Study of Thermal Performance for Chip-in-Substrate Package on Package**

*Tuan-Yu Hung<sup>1</sup>, Ming-Chih Yew<sup>1</sup>, Chan-Yen Chou<sup>1</sup> and Kuo-Ning Chiang<sup>2</sup>*  
National Tsing Hua University of Taiwan

14.50 **EMPC171 3D integration of ultra-thin functional devices inside standard multilayer flex laminates**

*W. Christiaens, T. Torfs, W. Huwel, C. Van Hoof, J. Vanfleteren*  
CMST (Ghent University - IMEC)

**15.15 EMPC192 Miniaturization of Printed Wiring Board Assemblies into System in a Package (SiP)**

*Steven G. Rosser, Irving Memis and Harry Von Hofen*  
Endicott Interconnect Technologies

**Reliability I**

**14.00 EMPC123 Thermo-mechanical Stress Analysis**

*Katrin Niehoff, Thomas Schreier-Alt, Florian Schindler-Saefkow, Hartmut Kittel*  
Fraunhofer IZM, Robert Bosch GmbH

**14.25 EMPC1 In-mould Integration of Electronics into Mechanics and Reliability of Overmoulded Electronic and Optoelectronic Components**

*Teemu Alajoki, Matti Koponen, Eveliina Juntunen, Jarmo Petäjä, Mikko Heikkinen, Jyrki Ollila, Aila Sitomaniemi, Topi Kosonen, Janne Aikio and Jukka-Tapani Mäkinen*  
VTT Technical Research Centre of Finland

**14.50 EMPC38 Assembly - Chip Interactions leading to PPM-level Failures in Microelectronic Packages**

*A. Mavinkurve, H. Cobussen, W.D. van Driel, M. van Dort and L. Endrinal*  
NXP Semiconductors

**15.15 EMPC163 Creep Mechanism Fractography Analysis on Sn-Pb Eutectic Solder Joint Failure**

*C. M. Oh<sup>1</sup>, C. W. Han<sup>1</sup>, N. C. Park<sup>1</sup>, S. B. Song<sup>1</sup>, B. J. Kang<sup>2</sup>, W. H. Kang<sup>2</sup> and W. S. Hong<sup>1</sup>*  
<sup>1</sup>Korea Electronic Technology Institute, <sup>2</sup>Samsung Electronics, Republic of Korea

**Microfluidic, Medical Device Packaging**

**14.00 EMPC145 Advanced Microfluidic Packaging for Molecular Diagnostics**

*Michele Palmieri*  
ST Microelectronics

**14.25 EMPC137 Processes for Integration of Microfluidic Based Devices**

*D.P. Webb, P.P. Conway, D.A. Hutt, B.J. Knauf and C. Liu*  
Loughborough University

**14.50 EMPC194 System packaging & integration for a swallowable capsule using a direct access sensor**

*Pio Jesudoss, Alan Mathewson, Bill Wright, Colm McCaffrey, Vladimir Ogurtsov, Karen Twomey and Frank Stam*  
Tyndall National Institute Cork Ireland

**15.15 EMPC170 Screen-Printed Polymer-Based Microfluidic And Micromechanical Devices Based On Evaporable Compounds**

*Nathalie Serra<sup>1</sup>, Thomas Maeder, Caroline Jacq, Yannick Fournier, Peter Ryser*  
Ecole Polytechnique Fédérale de Lausanne

**15.40 COFFEE BREAK IN THE EXHIBITION AREA**

**Evolution of Current Packaging Technologies Small form Factor**

**16.00 EMPC3 Trends in IC Packaging**

*Caroline Beelen-Hendriks*  
NXP Semiconductors

**16.25 EMPC110 Realisation of embedded-chip QFP packages Technological challenges and achievements**

*A.Ostmann<sup>1</sup>, D. Manassis<sup>2</sup>, L. Boettcher<sup>1</sup>, S. Karaszkievicz<sup>1</sup>, and H. Reichl<sup>2</sup>*  
<sup>1</sup>Fraunhofer Institute for Reliability and Microintegration (IZM), <sup>2</sup>Technical University of Berlin

**16.50 EMPC36 WPLGA: new package family for medium pin count with design flexibility**

*Pierangelo Magni, Giovanni Graziosi, Claudio-Maria Villa, Roberto Tiziani*  
STMicroelectronics

**17.15 EMPC158 DreamPak-Small Form Factor Package**

*L.A. Lim; Ramkumar Malliah*  
ASM Pacific Pte Ltd

**17.40 EMPC54 Next Generation Leadless RF Packages Utilizing 1st Level Low Cost Flip Chip Interconnect Technology**

*S. Walczyk, P. Dijkstra, N. Kramer, J. Verspeek*  
NXP Semiconductors

**Reliability II**

**16.00 EMPC72 The necessity of corrosion protection for solderable pure tin deposits on IC outer leads**

*Paolo Crema, Jürgen Barthelmes*  
ST Microelectronics, Atotech

**16.25 EMPC118 Accelerating the Temperature Cycling Tests of FBGA Memory Components with Lead-free Solder Joints without Changing the Damage Mechanism**

*Jan Reichelt, Przemyslaw Gromala, Sven Rzepka*  
Qimonda Dresden GmbH & Co.

**16.50 EMPC27 Hydrolysis testing of ACF joined flip chip components with conformal coating**

*Kati Kokko, Hanna Harjunpää, Pekka Heino, and Minna Kellomäki*  
Tampere University of Technology

**17.15 EMPC196 New packaging technology enabling integration of Magnetics and Semiconductors in one component**

*Abel Pot, Dr. Horst Roehm, Rinus v.d. Berg, Dr. Tamim P. Sidiki*  
DSM Engineering Plastics, NXP Semiconductors

**17.40 EMPC40 X-ray nanoCT of interconnections in IC packages: Visualizing of internal 3D-Structures with Submicrometer Resolution**

*Jens Luebbehuesen, Oliver Brunke, Holger Roth*  
GE Sensing & Inspection Technologies GmbH

**Ceramic Packages Including LTCC**

**16.00 EMPC200 A Comprehensive Overview on Today's Ceramic Substrate Technologies**

*Franz Bechtold*  
Via Electronic

**16.25 EMPC33 Structuration of zero-shrinkage self-constraining LTCC using mineral sacrificial materials**

*Thomas Maeder, Yannick Fournier, Caroline Jacq and Peter Ryser*  
Ecole Polytechnique Fédérale de Lausanne (EPFL)

**16.50 EMPC80 Robust LTCC/PZT Sensor-Actuator-Module for Aluminium Die Casting**

*M. Flösse<sup>(1)</sup>, U. Scheithauer<sup>(1)</sup>, S. Gebhardt<sup>(2)</sup>, A. Schönecker<sup>(2)</sup>, A. Michaelis<sup>(1)</sup>*  
<sup>(1)</sup>Technische Universität Dresden, <sup>(2)</sup>Fraunhofer Institut für Keramische Technologien und Systeme, Germany

**17.15 EMPC176 3D Integration Technologies for Ceramic Substrates in a SHM Application**

*Samuel Hildebrandt, Klaus-Jürgen Wolter*  
Dresden University of Technology

**17.40 EMPC156 Miniaturisation of a LTCC High-Frequency Rat-Race-Ring by using 3-dimensional integrated Passives and embedded High-K Capacitors**

*Rubén Perrone<sup>1</sup>, Jens Müller<sup>1</sup>, Polina Kapitanova<sup>2</sup>, Dmitry Kholodnyak<sup>2</sup>, Irina Vendik<sup>2</sup>, Stefan Humbla<sup>1</sup>, Matthias Hein<sup>1</sup>*  
<sup>1</sup>Ilmenau University of Technology, Germany, <sup>2</sup>Saint-Petersburg Electrotechnical University

**Assembly Technology I: Wirebonding I**

**16.00 EMPC10 Aluminum Ribbon on Power Device**

*Giuseppe Cristaldi, Giuseppe Malgioglio, Emanuele Scorfani*  
ST Microelectronics

**16.25 EMPC75 Mechanical properties and microstructure of heavy aluminum bonding wires for power applications**

*C. Dresbach<sup>1)</sup>, F. Naumann<sup>1)</sup>, M. Mittag<sup>1)</sup>, M. Petzold<sup>1)</sup>, T. Müller<sup>2)</sup>*  
<sup>1)</sup>Fraunhofer Institute for Mechanics of Materials, Germany <sup>2)</sup>W. C. Heraeus

**16.50 EMPC131 Surface-Enhanced Copper Bonding Wire for LSI and its Bond Reliability under Humid Environment**

*Tomohiro Uno*  
Nippon Steel Corporation

**17.15 EMPC122 Kirkendall voiding in Au ball bond interconnects on Al chip metallization at elevated temperatures from 100 - 200°C after optimizing intermetallic phase coverage**

*M. Schneider-Ramelow\*, St. Schmitz\*, B. Schuch\*\*, W. Gröbl\*\**  
\*Fraunhofer IZM, Germany, \*\*Conti Temic microelectronic GmbH

**17.40 EMPC41 Cu Wire Bonding: Reliability Improvement for High Temperature in Plastic Packages**

*C. Passagrilli, B. Vitali, R. Tiziani, C. Azzopardi*  
ST Microelectronics

**WEDNESDAY, JUNE 17<sup>TH</sup>**

**9.00 Power Packaging**

KEYNOTE: *N. Abbate*, STMicroelectronics

**9.40 Package Beyond 3D ICs to 3D Systems**

KEYNOTE: *R. Tummala*, Georgia Tech

**10.20 POSTER SESSION AND COFFEE BREAK IN THE EXHIBITION AREA**

**Advanced Packaging: wafer level Package I**

**11.20 EMPC82 Processing and Properties of AL-X Polymer Dielectric for Flip Chip and Wafer Level Packaging Applications**

*Phil Garrou, Alan Huffman, Jeff Piascik*  
Microelectronic Consultants of NC, RTI International

**11.45 EMPC91 Wafer Post-Processing for a Reconfigurable Wafer-Scale Circuit Board**

*Ricardo Izquierdo<sup>(1)</sup>, Moufid Radji<sup>(2)</sup>, Olivier Valorge<sup>(2)</sup>, Yves Blaquièrè<sup>(1)</sup>, Richard Norman, Yvon Savaria<sup>(2)</sup>*  
Université du Québec à Montréal<sup>(1)</sup>, École Polytechnique de Montréal<sup>(2)</sup>;  
McGill University Montréal, Canada

**12.10 EMPC21 Multifunctional Coatings for Wafer-Level Chip Scale Packaging**

*Candice Brannen, Russell Stapleton, Paul Hough*  
LORD Corporation, LORD Germany

**12.35 EMPC17 Wafer Level Packaging Fan Out thermal management: is smaller always hotter?**

*Donata Gualandris, Claudio M. Villa*  
STMicroelectronics

## High Power packaging Technology

- 11.20 EMPC47 Green high power density devices: challenges in materials science**  
*Antonino Scandurra<sup>a</sup>, Giuseppe Francesco Indelli<sup>a</sup>, Roberto Zafarana<sup>b</sup>, Angelo Cavallaro<sup>b</sup>, Emanuele Scrofan<sup>b</sup>, Jean Paul Girib and Salvatore Pignataro<sup>a,c</sup>*  
<sup>a</sup>Consorzio Catania Ricerche, c/o STMicroelectronics, Catania, <sup>b</sup>STMicroelectronics, <sup>c</sup>Dip. Scienze Chimiche Università di Catania
- 11.45 EMPC39 Small Size LTCC FlipChip-Package for RF-Power Applications**  
*Jens Müller<sup>1</sup>, Markus Noren<sup>2</sup>, Matthias Mach<sup>1</sup>, Sebastian Brunner<sup>2</sup>, Christian Hoffmann<sup>2</sup>*  
<sup>1</sup>TU Ilmenau, Germany, <sup>2</sup>EPCOS OHG
- 12.10 EMPC96 Development of Matrix Clip Assembly for Power MOSFET packages**  
*Martien Kengen<sup>1</sup>, Wil Peels<sup>1</sup>, David Heyes<sup>2</sup>*  
<sup>1</sup>NXP Semiconductors, the Netherlands - <sup>2</sup>NXP Semiconductors, England
- 12.35 EMPC88 Reliability Studies on the high current power MODULES with parallel MOSFETs**  
*G H Sarma et al. - Kaushik Mehta et al.*  
Si2Microsystems Bangalore India - Si2 Microsystems SanJose USA

## Electrical simulation

- 11.20 EMPC175 Electrical Modeling and Analysis of the Impact of Slits on Microstrip Lines in Thin Film Polymer Layers**  
*Ivan Ndip<sup>1</sup>, Michael Töpfer<sup>1</sup>, Karl-Friedrich Becker<sup>1</sup>, Matthias Hirte<sup>1</sup>, Ines Eidner<sup>1</sup>, Thorsten Fischer<sup>1</sup>, Jörg Bauer<sup>1</sup>, Wolfgang Scheel<sup>1</sup>, Stephan Guttowski<sup>1</sup>, Herbert Reichl<sup>1,2</sup>*  
<sup>1</sup>Fraunhofer Institute IZM, <sup>2</sup>Technische Universität Berlin
- 11.45 EMPC105 Impact of Package Parasitics on the EMC Performance of Smart Power SoCs**  
*Marco Merlin<sup>†</sup>, Franco Fiori<sup>†</sup>*  
<sup>†</sup>Istituto Superiore M. Boella, Torino, Politecnico di Torino
- 12.10 EMPC13 Advanced Modeling Techniques for System-level Power Integrity Analysis**  
*Giovanni Graziosi<sup>†</sup>, Patrice Joubert Doriol<sup>†</sup>, Yamarita Villavicencio<sup>†</sup>, Cristiano Forzan<sup>†</sup>, Mario Rotigni<sup>†</sup>, and Davide Pandini<sup>†</sup>*  
<sup>†</sup>STMicroelectronics, <sup>†</sup>Politecnico di Torino
- 12.35 EMPC166 Modelling of electrostatic coupling in 3D-IC architecture**  
*M. Rousseau<sup>1,3,4</sup>, O. Rozeau<sup>2</sup>, G. Le Carval<sup>2</sup>, M.-A. Jaud<sup>2</sup>, P. Leduc<sup>2</sup>*  
<sup>1</sup>STMicroelectronics, <sup>2</sup>CEA-LETI/MINATEC, <sup>3</sup>CNRS LAAS France, <sup>4</sup>Université de Toulouse

**13.00 LUNCH**

## Advanced Packaging: wafer level Package II

- 14.00 EMPC190 Reliability comparison of Aluminum Redistribution based WLCSP Designs**  
*Umesh Sharma, Phil Holland, and Harry Gee*  
California Micro Devices
- 14.25 EMPC201 The Third Dimension of eWLB**  
*T. Meyer<sup>1</sup>, A. Bahr<sup>2</sup>, G. Ofner<sup>1</sup>, R. Fürst<sup>3</sup>, X. Baraton<sup>4</sup>, Y. Seung Wook<sup>5</sup>*  
<sup>1</sup>Infineon Technologies Regensburg, Germany - <sup>2</sup>Infineon Technologies Singapore  
<sup>3</sup>Infineon Technologies Neubiberg, Germany - <sup>4</sup>STMicroelectronics, Singapore  
<sup>5</sup>STATS ChipPAC, Singapore
- 14.25 EMPC160 Thin Hermetic Borosilicate Glass Layers for Highly Reliable Chip-Passivations in Wafer-Level-Packaging**  
*Ulli Hansen, Jürgen Leib, Simon Maus, Oliver Gyenge, Michael Töpfer*  
MSG Lithoglas, Fraunhofer IZM
- 15.15 EMPC146 Encapsulation Challenges for Wafer Level Packaging**  
*Eric Kuah, Hao Ji Yuan (PhD), Li Qiu Fang, Ding Jia Pei (PhD), Chan Wei Ling, & SC Ho*  
ASM Technology Singapore Pte Ltd Encapsulation Solution Group (ESG)

## High Power Packaging: Thermal modeling and Management

- 14.00 EMPC109 Development of space grade power hybrid for Reaction Wheel drive electronics: Challenges and criticalities**  
*Krishnamohan Nutheti, Prabhu Dass, GR Joshi, Vedprakash and Vinod S Chippalkatti*  
K.S. Mani\*, K.P. Lilly\*, M. Suresh\*, T.R. Haridas\* and Robert Devasahayam\*  
Centum Electronics Limited, <sup>†</sup>ISRO Inertial systems unit
- 14.25 EMPC143 Passive Phase Change Tower Heat Sink & Pumped Coolant Technologies for Next Generation CPU Module Thermal Designs**  
*M. Vogel, D. Copeland, A. Mastro, S. Kang, B. Whitney, G. Upadhyaya M. Connors, J. Marsala*  
Sun Microsystems - Aavid Thermalloy - Cooligy - Thermacore - Thermal Form and Function
- 14.50 EMPC103 A new methodology for multi-level thermal characterization of complex electronic systems : from die to board level**  
*Martins Olivier<sup>1</sup>, Peltier Nicolas<sup>2</sup>, Guedon Stéphane<sup>2</sup>, Kaiser Sylvian<sup>2</sup>, Marechal Yves<sup>1</sup>, and Avenas Yvan<sup>1</sup>*  
<sup>1</sup>G2ELAB, INPG-UJF-CNRS, France - <sup>2</sup>DOCEA Power, France
- 15.15 EMPC102 Thermal Design Considerations on Wirebond-Packages**  
*M. Mach, Dr. J. Müller*  
BMBF Center for Innovation Competence MacroNano®, TU Ilmenau

## Sensor Packaging

- 14.00 EMPC189 Low energy consumption thick-film pressure sensors**  
*Darko Belavič<sup>1</sup>, Marina Santo Zarnik<sup>1</sup>, Matej Možek<sup>4</sup>, Sandi Kocjan<sup>3</sup>, Marko Hrovat<sup>2</sup>, Janez Holc<sup>2</sup>, Mitja Jerlah<sup>3</sup>, Srečko Maček<sup>2</sup>*  
<sup>1</sup>HIPOT-RR, Slovenia - <sup>2</sup>Jožef Stefan Institute, Slovenia - <sup>3</sup>HYB, Slovenia - <sup>4</sup>Faculty of Electrical Engineering, Slovenia
- 14.25 EMPC63 The Design and Improvement of LTCC-based Capacitive Pressure Sensors employing Finite Element Analysis**  
*C. Ionescu<sup>a</sup>, P.Svasta<sup>a</sup>, C. Marghescua, M. Santo Zarnik<sup>b</sup>, D. Belavič<sup>b</sup>*  
<sup>a</sup>University "Politehnica" of Bucharest, UPB-CETTI - <sup>b</sup>HIPOT-RR, Slovenia
- 14.50 EMPC95 Evaluation of Printed Electronics Manufacturing Line with Sensor Platform Application**  
*Kimmo Kaija, Eerik Halonen, Ville Pekkanen, and Matti Mäntysalo*  
Tampere University of Technology, Finland
- 15.15 EMPC81 SMD Pressure and Flow Sensors for Industrial Compressed Air in LTCC Technology**  
*Yannick Fournier, Aurélie Barras, Thomas Maeder, Peter Ryser*  
Laboratoire de Production Microtechnique Ecole Polytechnique Fédérale de Lausanne (EPFL), Switzerland

## Materials: Adhesives Properties and reliability I

- 14.00 EMPC4 Temporary adhesives for wafer bonding: Deep reactive ion etching application**  
*Djaffar BELHARET<sup>1,2</sup>, Pascal DUBREUIL<sup>1,2</sup>, David COLIN<sup>1,2</sup>, Laurent MAZENQ<sup>1,2</sup>, Hugues GRANIER<sup>1,2</sup>*  
CNRS; LAAS; <sup>2</sup>Université de Toulouse; UPS, INSA, INP, ISAE; LAAS
- 14.25 EMPC45 Experimental study of polymers as encapsulating materials for photovoltaic modules**  
*Simone Sala, Marco Campaniello, Alessandro Bailini*  
PV Laboratory, SEM S.r.l
- 14.50 EMPC87 Process Characterization of DuPont MXAdvance 140 Dry Film Photoresist for High Resolution Application**  
*Hao Yun and Chester Balut, Alan Huffman*  
DuPont Electronic Technologies, RTI International
- 15.15 EMPC62 Fracture Toughness Assessment of ACF Flip-chip packages under High Moisture Condition with Moire Interferometry**  
*Jin-Hyoung Park, Kyung-Woon Jang, Kyung-Wook Paik, and Soon-Bok Lee*  
Department of Mechanical Engineering KAIST, Korea

**15.40 COFFEE BREAK IN THE EXHIBITION AREA**

## Advanced Packaging: 3D packaging I

- 16.00 EMPC71 3D packaging and supply chain management**  
*Paul Collander*
- 16.25 EMPC86 3DIC products using TSV for mobile phone applications: An industrial perspective**  
*Yann Guillou, Anne-Marie Dutron*  
ST-NXP Wireless
- 16.50 EMPC121 3D Integration with AC coupling for Wafer-Level Assembly**  
*M. Scandiuzzo<sup>a</sup>, L. Perugini<sup>a</sup>, R. Cardu<sup>b</sup>, M. Innocenti<sup>a</sup>, R. Canegallo<sup>a</sup>*  
<sup>a</sup>STMicroelectronics, <sup>b</sup>University of Bologna
- 17.15 EMPC164 Direct interconnection of chemical mechanical polishing (CMP)-Cu thin films at 150°C in ambient air**  
*Akitsu Shigetou<sup>1</sup>, and Tadatomo Suga<sup>2</sup>*  
<sup>1</sup>National Institute for Materials Science, Japan, <sup>2</sup>The University of Tokyo
- 17.40 EMPC51 Introduction of a unified equipment platform for UV initiated processes in conjunction with the application of electrostratic carriers as thin wafer handling solution**  
*Dietrich Tönnies, Markus Gabriel, Barbara Neubert, Ran Ji, Ralph Zoberbier, Margarete Zoberbier, Reinhard Völkel, Michael Töpfer, Tobias Baumgartner, Ingo Gräding, Roland Raschke, Ira Balaj*  
SUSS MicroTec, Fraunhofer IZM, Protec Carrier Systems

## Materials: Solder Joint Properties and reliability II

- 16.00 EMPC147 Mechanical behaviour of SAC-lead free solder alloys with regard to the size effect and the crystal orientation**  
*Villain, Juergen; Mueller, Wolfgang; Saeed, Usman Weippert*  
University of Applied Sciences, Germany
- 16.25 EMPC148 NanoBond® Assembly - A Rapid, Room Temperature Soldering Process**  
*Greg Caswell*  
Reactive Nano Technologies
- 16.50 EMPC79 New developments in high performance solder products for power die assemblies**  
*Mike Fenner*  
Indium Corporation
- 17.15 EMPC185 Au-Sn SLID bonding: Fluxless bonding with high temperature stability, to above 350oC.**  
*Knut Aasmundtveit<sup>a</sup>, Kaiying Wang<sup>a</sup>, Nils Hoivik<sup>a</sup>, Joachim Moe Graff<sup>b</sup>, Anders Elfving<sup>c</sup>*  
<sup>a</sup>Vestfold University College, Norway, <sup>b</sup>SINTEF Materials and Chemistry, clnfineon Technologies SensoNor AS

- 17.40 EMPC100 Long Term Joint Reliability of SiC Power Devices at 330**  
*Fengqun Lang<sup>1</sup>, Satoshi Tanimoto<sup>2,3</sup>, Yusuke Hayashi<sup>1</sup>, Hiromichi Ohashi<sup>1</sup>, Hiroshi Yamaguchi<sup>1</sup>*  
<sup>1</sup>Institute of Advanced Industrial Science and Technology (AIST), Japan  
<sup>2</sup>Research and Development Association for Future Electron Devices (FED), Japan  
<sup>3</sup>Nissan Motor Co. Ltd

## Assembly Technology II

- 16.00 EMPC124 Simulation and experimental analysis of substrate overmolding**  
*Thomas Schreier-Alt*  
 Fraunhofer IZM
- 16.25 EMPC74 Local hardening behavior of free air balls and heat affected zones of thermosonic wire bond interconnections**  
*C. Dresbach<sup>1</sup>, G. Lorenz<sup>1</sup>, M. Mittag<sup>1</sup>, M. Petzold<sup>1</sup>, T. Müller<sup>1</sup>*  
 Fraunhofer Institute for Mechanics of Materials<sup>2</sup> W. C. Heraeus
- 16.50 EMPC202 Compression Molding solutions for various high end Package applications and cost savings for standard Package applications**  
*Hideaki Matsutani*  
 Towa Corporation
- 17.15 EMPC173 Advanced Failure Analysis Methods and Microstructural Investigations of Wire Bond Contacts for Current Microelectronic System Integration**  
*R. Klengel, S. Bennemann, M. Krause, Chr. Schmidt, M. Petzold*  
 Fraunhofer Institute for Mechanics of Materials
- 17.40 EMPC203 Advanced Solutions for Ultra-thin Wafers and Packaging**  
*Gerald Klug*  
 Disco

## Substrates and Interconnects

- 16.00 EMPC138 High Linearity and Broadband WiMAX Power Amplifier Design Using Board Level Integration Technology**  
*Wei-Ting Chen, Kuo-Chiang Chin, Cheng-Hua Tsai, Li-Chi Chang, Yung-Chung Chang, and Chang-Chih Liu*  
 Industrial Technology Research Institute (ITRI), Taiwan
- 16.25 EMPC8 Packaging and wired interconnections for insertion of miniaturized chips in smart fabrics**  
*Jean Brun, Dominique Vicard, Bruno Mourey*  
 CEA-LETI
- 16.50 EMPC67 Fully embedded optical and electrical interconnections in flexible foils**  
*E. Bosman, G. Van Steenberge, P. Geerinck, J. Vanfleteren and P. Van Daele*  
 Ghent University

- 17.15 EMPC197 Large panel, highly flexible multilayer thin film boards**  
*Hans Burkard, Wolfgang Kapischke, Josef Link*  
 Hightec MC AG, Lenzburg, Switzerland
- 17.40 EMPC180 A new low cost, elastic and conformable electronic technology for soft and stretchable electronic devices**  
*Frederick Bossuyt*  
 University of Ghent

## THURSDAY, JUNE 18<sup>TH</sup>

- 9.00 Mems the future man machine interface**  
 KEYNOTE: *B. Vigna*, STMicroelectronics
- 9.40 Heterogeneous Integration for System in Package**  
 KEYNOTE: *H. Reichl*, Fraunhofer IZM

**10.20 COFFEE BREAK IN THE EXHIBITION AREA**

## Advanced Packaging: 3D packaging II

- 10.40 EMPC101 Chip to Chip bonding using micro-Cu bumps with Sn capping layers**  
*Jin Soo Lee and Young-Ho Kim*  
 Hanyang University, Korea
- 11.05 EMPC172 3D integration process flow for set-top box application: description of technology and electrical results**  
*S. Cheramy<sup>(1)</sup>, D. Henry<sup>(1)</sup>, A. Astier<sup>(1)</sup>, J. Charbonnier<sup>(1)</sup>, P. Chausse<sup>(1)</sup>, M. Neyret<sup>(1)</sup>, C. Brunet-Manquat<sup>(1)</sup>, S. Verrun<sup>(1)</sup>, N. Sillon<sup>(1)</sup>, L. Bonnot<sup>(2)</sup>, X. Gagnard<sup>(2)</sup>, J. Vittu<sup>(3)</sup>*  
<sup>(1)</sup>CEA Léti - MINATEC, <sup>(2)</sup>STMicroelectronics, <sup>(3)</sup>STMicroelectronics
- 11.30 EMPC161 Modeling and Quantification of Conventional and Coax-TSVs for RF Applications**  
*Ivan Ndip<sup>1</sup>, Brian Curran<sup>1</sup>, Stephan Guttowski<sup>1</sup>, Herbert Reichl<sup>1,2</sup>*  
<sup>1</sup>Fraunhofer Institute IZM, <sup>2</sup>Technische Universität Berlin
- 11.55 EMPC162 Stacking of Full Rebuilt Wafers for Sip and Abandoned Sensors / Applications**  
*Christian Val, Pascal Couderc, Nadia Boulay Jean-Charles Souriau*  
 3D Plus, CEA-LETI Minatec

## Mems System Packaging

**10.40 EMPC2 A 3-D packaging concept for cost effective packaging of MEMS and ASIC on wafer level**

*Tobias Baumgartner, Michael Töpper, Matthias Klein, Bernhard Schmid, Heikki Kuisma, Sami Nurmi, Hannu Kattelus, James Dekker, Ralph Schachler*  
Fraunhofer-Institut

**11.05 EMPC53 Encapsulation of the Next Generation advanced Mems& Sensor Microsystems**

*Ton van Weelden*  
Boschman Technologies B.V.

**11.30 EMPC55 BCB-based wafer-level packaging of integrated CMOS/SOI piezoresistive accelerometer**

*Dominik Weiland\*, Aboubacar Chaehoi\*, Diarmuid O'Connell\*, Mark Begbie\*, Changhai Wang\*\*, Shona Ray\*\*\**  
\*Institute for System Level Integration, Livingston, \*\*Heriot Watt University, Edinburgh, \*\*\*Semefab Ltd

**11.55 EMPC168 Versatile MEMS and MEMS integration technology platforms for cost effective MEMS development**

*Philip Pieters*  
IMEC

## Materials: Adhesives Properties and Reliability II

**10.40 EMPC184 Thermo Mechanical Characterization of Packaging Polymers**

*Bjoern Boehme1, K.M.B. Jansen2, Sven Rzepka3, Klaus-Juergen Wolter1*  
1)Technische Universität Dresden - 2)Delft University of Technology - 3)Qimonda Dresden

**11.05 EMPC106 Characteristics of Electrically Conductive Adhesives filled with Copper Nanoparticles with Organic Layer**

*LiNgee Ho\*, Hiroshi Nishikawa\*, Tadashi Takemoto\*, Yukiyasu Kashiwagi\*\*, Mari Yamamoto\*\*, Masami Nakamoto\*\**  
\*Osaka University, \*\*Osaka Municipal Technical Research Institute

**11.30 EMPC22 Highly Conductive Adhesives via Novel Heterogeneous Structures**

*T.D. Fornes, P.W. Hough*  
LORD Corporation, LORD Germany GmbH

**11.55 EMPC182 Comparison between Die Attach Film (DAF) and Film Overover Wire (FOW) on Stack-die CSP Application**

*C.L. Chung, C.W. Ku, H.C. Hsu and S. L. Fu*  
I-SHOU University, Taiwan

## IMAPS Global Business Council Photovoltaics

**10.40 APOLLON: the Large Integrated European Project of FP7 on Concentrating Photovoltaic, target objectives on technology and cost**

*Gianluca Timo*  
CESI RICERCA

**11.05 Crystalline Si Solar Cells: Markets and Technology**

*Andy London*  
Hereaus

**11.30 Photovoltaic Present and Future - The Si potentialities**

*Domenico Sartore*  
Estelux S.p.a

**11.55 TBA**

**12.30 Technology Knowledge Gaps Projects arising from the iNEMI Technology Roadmap**

*B. Pfahl, J. Arnold and G. O'Malley, INEMI*

**12.50 Economic Recovery Through Technological Innovation and Creativity**

*Chuck Bauer*

**13.10 Conference Close and preview ESTC2010 and EMPC2011**

TUESDAY, JUNE 16<sup>TH</sup>  
WEDNESDAY, JUNE 17<sup>TH</sup>

10.30 - 11.20  
10.20 - 11.20

## Poster Session

### EMPC5 Integrated LTCC-glass microreactor and $\mu$ TAS with thermal stabilization for biological application

*Pawel Bembnowicz, Dorota Nowakowska, Leszek J.*  
Wroclaw University of Technology, Poland

### EMPC6 Fabrication & characterization of S-band power amplifier MMIC (GaAs Die) implemented in hybrid fixture.

*Bhatti Nadeem Shahzad*  
National Engineering & Scientific Commission (Nescom), Islamabad

### EMPC7 High speed packaging solutions for LiNbO3 electro-optical modulator

*Stefano Bonino, Roberto Galeotti, Luigi Gobbi*  
Avanex

### EMPC14 MEMS Pressure sensors - new LGA Packagings

*Lorenzo Baldo\*, Mark Azzopardi\*\*, Fulvio Fontana\*\*\*, Selma Gatt \*\**

\*ST MEMS & Healthcare, \*\*ST Microelectronics Corporate Packaging and Automation

\*\*\*ST Microelectronics Corporate Packaging and Automation

### EMPC23 Application of 3D modeling tools for advanced packaging on a broad range of industrial applications

*Yvon IMBS<sup>1</sup>, Laurent MARECHAL<sup>1</sup>, David AUCHERE<sup>1</sup>, Giovanni GRAZIOSI<sup>2</sup>, Jason DEBONO<sup>3</sup>*  
STMicroelectronics Grenoble<sup>1</sup>, Agrate<sup>2</sup>, Kirkop<sup>3</sup>

### EMPC24 Experimental Characterization Of Thermo-Mechanical Properties Of Lead-Based Solders For Power Electronics Packaging Reliability Applications

*S. JACQUES<sup>(a)(b)</sup>, J. ROUBION<sup>(c)</sup>, N. BATUT<sup>(b)</sup>, R. LEROY<sup>(c)</sup>, L. GONTHIER<sup>(a)(b)(a)</sup>*

<sup>(a)</sup>STMicroelectronics - <sup>(b)</sup>Laboratoire de Microélectronique de Puissance (LMP)", University of Tours, France - <sup>(c)</sup>Laboratoire de Mécanique et Rhéologie (LMR)", University of Tours

### EMPC31 Package design for alleviating stress in materials embedded with electronic systems

*Maryna Lishchynska, Kieran Delaney*  
Cork Institute of Technology

### EMPC32 Development of low-firing lead-free thick-film materials for piezoresistive sensors on steel substrates

*Caroline Jacq, Thomas Maeder, and Peter Ryser*  
Ecole Polytechnique Fédérale de Lausanne

### EMPC35 Electromagnetic Simulations For The Packaging Design Of Telecommunication Component

*L. Maggi, G. Ticozzi*  
PGT PHOTONICS SpA

### EMPC42 Size and Microstructure Effects on the Stress-Strain Behaviour of Lead Free Solder Joints

*Pradeep Hegde, David C. Whalley and Vadim V. Silberschmidt*  
Loughborough University, UK

### EMPC46 Fine D.A. Delamination analysis by Acoustic Microscope

*G. Santospirito, A. Terzoli*  
ST Microelectronics

### EMPC49 Modeling of Flip Chip Bump Patterns to minimize Crosstalk on a BU-BGA package design

*Pierre Brunet, Keith Sheach, Gordon Xiang*  
High Speed Package Design, Ottawa Design Center, STMicroelectronics

### EMPC58 Latest Plasma Cleaning Technology

*Reinhard Windemuth*  
Panasonic Industrial Europe GmbH

### EMPC59 A Study on High-density High-speed SerDes Design in Buildup Flip Chip Ball Grid Array Packages

*Gordon Xiang, Pierre Brunet, Keith Sheach*  
High Speed Package Design, Ottawa Design Center, STMicroelectronics

### EMPC60 Novel methodology for analyzing variation risk introduced by the manufacturing and/or assembly process in Microsystems

*Yunfei Sun<sup>1</sup>, Clifford R Fowkes<sup>2</sup>, Nabil Gindy<sup>1</sup>*

<sup>1</sup>University of Nottingham, UK - <sup>2</sup>Knowledge Transfer Network, UK

### EMPC61 Deposition and characterization of electroless Ni-Co-P alloy for diffusion barrier applications

*Anuj Kumar, Mukesh Kumar\*, Dinesh Kumar*  
Kurukshetra University

### EMPC64 Investigation of Solder Joints by Thermographical Analysis

*P. Svasta<sup>a</sup>, C. Ionescu<sup>a</sup>, N.D. Codreanu<sup>a</sup>, D. Bonfert<sup>b</sup>*

<sup>a</sup>University "Politehnica" of Bucharest - <sup>b</sup>PS, Fraunhofer Institute Reliability and Microintegration / IZM-M

### EMPC70 Metal Trace Impact Life Prediction Model for Stress-Buffer-Enhanced Package

*Chan-Yen Chou, Chao-Jen Huang, Masafumi Sano, and Kuo-Ning Chiang*  
National Tsing Hua University, HsinChu, Taiwan

### EMPC73 Pot Life Improvement of Low Temperature and High-speed Curable Anisotropic Conductive Adhesive

*Jong-Hyun Lee\*, Ju-Hyung Kim, Chang-Yong Hyun*  
Seoul National University of Technology

### EMPC77 Thermoelastic Properties of Printed Circuit Boards II: Effect of Copper Trace

*Hu Guojun, Goh Kim Yong, Luan Jing-en, Lim Wee Chin and Xavier Baraton*  
STMicroelectronics

**EMPC84 Experimental analysis on the mechanism of moisture induced interface weakening in ACF package**

*Gi-Dong Sim*

KAIST - Korea

**EMPC90 Solder Process Optimization: Influence of Heating and Cooling Rate on the Thermo-Mechanical Stress Generated in Components**

*Michael Hertl, Diane Weidmann, Jean-Claude Lecomte*

INSIDIX

**EMPC99 Electrostatic wafer handling for thin wafer processing**

*Christof Landesberger, Robert Wieland, Armin Klumpp, Peter Ramm, Andreas Drost, Ulrich Schaber, Detlef Bonfert, Karlheinz Bock*

Fraunhofer-Institute for Reliability and Microintegration IZM

**EMPC108 Design and Fabrication of Corrosion and Humidity Sensors for Performance Evaluation of Chip Scale Hermetic Packages for Biomedical Implantable Devices**

*Nooshin Saeidi*

University College London

**EMPC111 Far-End Maximum Crosstalk for Coupled Lines as a Function of Load**

*Amir Owzar, Ralph Stephan, Wesley Petersen, Markus Helfenstein*

ST-Wireless

**EMPC113 Optimization of thermomechanical reliability of WLCSP packages**

*AMIR R PAKDEL*

PMC-SIERRA INC.

**EMPC114 Effects of test conditions on bending impact of lead free solder**

*JAIHYUN PARK*

RIST - South korea

**EMPC115 Connector reliability testing using salt spray**

*A. Parviainen, J. Perälä, S. Kuusiluoma, and L. Frisk*

Tampere University of Technology

**EMPC119 Bisected thermodynamic sensor as the power AC/DC transmitter**

*Řezníček Michal<sup>(1)</sup>, Szendiuch Ivan<sup>(1)</sup>, Řezníček Zdeněk, Jr.<sup>(2)</sup>, Řezníček Zdeněk, Sr.<sup>(3)</sup>,*

<sup>(1)</sup>Department of Microelectronics, Brno University of Technology - <sup>(2)</sup>Department of Radio Electronics, Brno University of Technology - <sup>(3)</sup>HIT Ltd, Czech Republic

**EMPC125 Mechanical and Microstructural Properties of SiC-Mixed Sn-Bi Solder Bump**

*Chang-Woo Lee, Yue-Seon Shin, Sehyung Lee, Sehoon Yoo*

Korea Institute of Industrial Technology

**EMPC128 New Facts from Lead-free Solders Reliability Investigation**

*Ivan Szendiuch, Jaroslav Jankovsky*

Brno University of Technology

**EMPC134 Novel interconnection processes for low cost PEN/PET substrates**

*Jeroen van den Brand<sup>1</sup>, Roel Kusters<sup>1,2</sup>, Henri Fledderus<sup>1</sup>, Eric-Jan Rubingh<sup>1</sup>, Tomas Podprocky<sup>3</sup>, Andreas Dietzel<sup>1</sup>*

<sup>1</sup>Holst Centre/TNO - Netherlands Organisation for Applied Scientific Research, <sup>2</sup>TNO Science and Industry - Netherlands Organisation for Applied Scientific Research, <sup>3</sup>Imec

**EMPC135 Characterization of PTC resistor pastes applied in LTCC technology**

*J. Vanek, W. Smetana<sup>1)</sup>, I. Szendiuch*

Brno University of Technology, Brno, Czech Republic - <sup>1)</sup>Vienna University of Technology

**EMPC139 Influence of the Fabrication Errors on Multilayer Thick Film Circuits**

*Wesam Ali<sup>1</sup>, Chunwei Min, Nurul Osman<sup>2</sup>, and Charles Free<sup>2</sup>*

<sup>1</sup>College of Technological Studies, Kuwait - <sup>2</sup>University of Surrey

**EMPC142 Investigation of the Relationship between Material Selections and Moisture Sensitivity Levels of Quad Flat No-lead (QFN) Packages**

*Minshu Zhang and S. W. Ricky Lee*

Hong Kong University of Science and Technology, Clear Water Bay

**EMPC150 Solder Materials for IGBT Usage**

*Mike Fenner*

Indium Corporation

**EMPC154 Moisture Sensitivity Level One(1) And Green Packaging Solution For A Nickel-Palladium-Gold (Nipdau) Pre-Plated Frames**

*Alvin B. Denoyo*

Cypress Manufacturing Ltd

**EMPC159 Fatigue Life Prediction of Plated Through Holes(PTH) under Thermal Cycling**

*No-Chang Park, Chul-Min Oh, Byeong-Suk Song, Chang-Woon Han, Won-Sik Hong*

Korea Electronics Technology Institute

**EMPC165 Damage Risk Assessment of Under-Pad Structures in Vertical Wafer Probe Technology**

*Torsten Hauck\*, Ilko Schmadlak\*, Wolfgang H. Müller\*\**

\*Freescale Halbleiter Deutschland GmbH - \*\*Technische Universität Berlin

**EMPC169 Reliability Testing of Frequency Converters with Salt Spray and Temperature Humidity Tests**

*Janne Kiilunen, Laura Frisk*

Tampere University of Technology

**EMPC174 Effects of Defects on the Thermal and Optical Performance of High Brightness Light Emitting Diodes**

*Liuxi Tan<sup>1,2</sup>, Jia Li<sup>1,2</sup>, Kai Wang<sup>1,3</sup>, Sheng Liu<sup>1,2,3\*</sup>*

<sup>1</sup>Huazhong University, China - <sup>2</sup>School of Mechanical Engineering, Huazhong University, China - <sup>3</sup>School of Optoelectronics Science and Engineering, Huazhong University, China

**EMPC178 Modeling of hygrothermal behavior of enclosed device:  
Effects of mechanics and materials**

*Galkin Timo*

Nokia Siemens Networks

**EMPC183 A Novel Thermo-Mechanical Method of Fatigue Characterization of Real  
Solder Joints**

*R. Metasch\*, M. Röllig\*\*, K.-J. Wolter*

\*TU-Dresden - \*\*Fraunhofer Institut für Zerstörungsfreie Prüfverfahren

**EMPC187 Optimization of Flip-chip Laser Soldering for Low Temperature Stability  
Substrate**

*Tamás Hurtony, Bálint Balogh, Péter Gordon*

Budapest University of Technology and Economics

**EMPC193 Long Term Stability of Polymer Based Resistors Tested by Noise,  
Non-Linearity and Electro-Ultrasonic Spectroscopy**

*V. Sedlakova, P. Tofel, J. Sikula*

Brno University of Technology

**EMPC195 Interface Resistance between Polymer Based Conducting and Resistive  
Layers**

*V. Sedlakova, P. Tofel, M. Chvatal, J. Sikula*

Brno University of Technology